



EFN

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q77024

Shoichiro YASUNAMI, et al.

Appln. No.: 10/642,291

Group Art Unit: 1752

Confirmation No.: 2020

Examiner: John S.Y. Chu

Filed: August 18, 2003

For: NEGATIVE RESIST COMPOSITION

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 7, 2006, please amend the above-identified application as follows on the accompanying pages.

**TABLE OF CONTENTS**

AMENDMENTS TO THE CLAIMS.....	2
REMARKS.....	8